



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 1743

<b>SERIAL NUMBER</b> 10/826,823	<b>FILING OR 371(c) DATE</b> 04/15/2004 <b>RULE</b>	<b>CLASS</b> 355	<b>GROUP ART UNIT</b> 2851	<b>ATTORNEY DOCKET NO.</b> (Z)98003 PUS2
------------------------------------	---	---------------------	-------------------------------	---

## APPLICANTS

Christian Wagner, Aalen, GERMANY;  
 Michael Trunz, Ellwangen, GERMANY;  
 Ralf Hilgers, Aalen, GERMANY;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 09/934,817 08/21/2001 *22*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

GERMANY 198 07 094.2 02/20/1998 *22*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 06/30/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> GERMANY	<b>SHEETS DRAWING</b> 5	<b>TOTAL CLAIMS</b> 46	<b>INDEPENDENT CLAIMS</b> 8
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>S. J. K.</i> Examiner's Signature Initials				

## ADDRESS

M. Robert Kestenbaum  
 11011 Bermuda Dunes NE  
 Albuquerque, NM87111

## TITLE

Optical arrangement and projection exposure system for microlithography with passive thermal compensation

<b>FILING FEE RECEIVED</b> 1668	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
		<input type="checkbox"/> 1.18 Fees ( Issue )
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit